

**The Hong Kong Polytechnic University**  
**Subject Description Form**

<b>Subject Code</b>	AMA503				
<b>Subject Title</b>	Statistics and Data Analytics				
<b>Credit Value</b>	3				
<b>Level</b>	5				
<b>Pre-requisite / Co-requisite/ Exclusion</b>	Nil				
<b>Objectives</b>	This subject introduces students fundamental theories and methods of statistics and data analysis that are useful for improving processes in semiconductor manufacturing.				
<b>Intended Learning Outcomes</b>	<p>Upon completion of the subject, students will be able to:</p> <p>(a) understand the principle of data analytics and data mining;</p> <p>(b) apply various data analytics algorithms and techniques to analyze data related to semiconductor manufacturing;</p> <p>(c) carry out in-depth data analysis for the optimization of semiconductor processing and device fabrication.</p>				
<b>Subject Synopsis/ Indicative Syllabus</b>	<p><b>Overview of statistics and data analytics:</b> Introduction to the use of data mining and analysis in semiconductor industries.</p> <p><b>Analytics algorithms and techniques:</b> Data analysis methods include principal component analysis, independent component analysis, hypothesis testing, linear and logistic regression, autoregressive–moving-average, autoregressive integrated moving average and analysis of variance. Understanding of other computational intelligence and advanced analytics techniques.</p> <p><b>Programming languages and tools for data analytics:</b> Python, R programming, Excel, SAS, etc.</p> <p><b>Examples of using analytics technique in semiconductor industries:</b> Data provided by the semiconductor industries for data analysis and optimization purpose.</p>				
<b>Teaching/Learning Methodology</b>	This subject is mainly delivered through lectures and programming training. The teaching and learning approach is mainly problem-solving oriented. The approach aims at the development of data analytics techniques and how the techniques can be applied to problem solving. Students are encouraged to adopt a deep study approach by employing high level cognitive strategies, such as critical and evaluative thinking, relating, integrating and applying theories to practice.				
<b>Assessment Methods in Alignment with Intended Learning Outcomes</b>	Specific assessment methods/tasks	% weighting	Intended subject learning outcomes to be assessed (Please tick as appropriate)		
			a	b	c
	1. Continuous Assignments	25%	✓	✓	✓
	2. Project	30%			✓
	3. Examination	45%	✓	✓	✓

	Total	100 %	
	<p><b>Continuous Assignments:</b> includes participation in the computer laboratory sessions and turning on time the graded quizzes to check students' progress throughout the semester.</p> <p><b>Project:</b> will be assigned during the second half of the semester. Students will use their knowledge gained in the class/lab to tackle problems related to data analytics in semiconductor manufacturing.</p> <p><b>Examination:</b> assess the knowledge acquired by the students, as well as to determine the extent to which they have achieved the intended learning outcomes.</p>		
<b>Student Study Effort Expected</b>	Class contact:		
	▪ Lecture		26 Hrs.
	▪ Computer Laboratory		13 Hrs.
	Other student study efforts:		
	▪ Assignment/Projects		51 Hrs.
	▪ Reading and self-study		30 Hrs.
	The total student study effort		
<b>Reading List and References</b>	<p>N.R. Pal and L. Jain (Eds), Advanced Techniques in Data Mining and Knowledge Discovery, Springer, 2005 (Chapter 2, Advanced Methods for the Analysis of Semiconductor Manufacturing Process Data).</p> <p>R. Peck, C. Olsen and J. Devore, Introduction to Statistics and Data Analysis, 3<sup>rd</sup> Ed, Thomson Higher Education, 2008.</p> <p>S. Bagchi <i>et al</i>, Data analytics and stochastic modeling in a semiconductor fab, Appl. Stochastic Models Bus. Ind., 26:1–27, 2010.</p> <p>G. James, D. Witten, T. Hastie, and R. Tibshirani, An Introduction to Statistical Learning – with Applications in R, 2<sup>nd</sup> Ed, Springer 2021 (<a href="https://web.stanford.edu/~hastie/ISLR2/ISLRv2_website.pdf">https://web.stanford.edu/~hastie/ISLR2/ISLRv2_website.pdf</a>).</p>		